

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. EGUCHI, et al.
Serial No.: 10/588,959
Filed: AUGUST 10, 2006
For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE
Group AU: 2891
Examiner: Julia Slutsker
Confirm. No: 4026

STATEMENT OF SUBSTANCE OF INTERVIEW

Mail Stop: AMD – NO FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 11, 2009

Sir:

The Interview Summary dated August 11, 2009, in connection with the above-identified application, for the interview conducted on August 4, 2009, is noted. This Interview Summary sets forth that during the interview, the undersigned indicated that a RCE was filed requesting entry of claim 1 as amended in the Amendment After Final Rejection filed July 6, 2009; and during the interview differences between the invention as set forth in such amended claim 1 and the previously applied prior art was discussed. The undersigned agrees with the comments by the Examiner in the Interview Summary, as set forth in the foregoing.

It is respectfully submitted that the foregoing constitutes the necessary Statement of the substance of the interview as required in the aforementioned Interview Summary.

To the extent necessary, Applicants hereby petition for an extension of time under 37 CFR 1.136. Kindly charge any shortage of fees due in connection with the filing of this paper, including any extension of time fees, to the Deposit Account of

Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (case 1374.46346X00),
and please credit any overpayments to such Deposit Account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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